



Patent
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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of)
David W. SHERRER et al)
Application No: 09/519,165)
Filed: March 6, 2000)
FOR: SINGLE MASK LITHOGRAPHIC)
PROCESS FOR PATTERNING)
MULTIPLE TYPES OF SURFACE)
FEATURES)

Group Art Unit: 1772
Examiner: W. P. Watkins, III
Confirmation No: 8879

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AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

Sir:

In response to the Official Action issued July 31, 2003, applicants submit the following amendments and remarks.

Amendments to the claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 7 of this paper.